

**UNITED STATES
PATENT AND TRADEMARK OFFICE**



USPTO IP5 Statistic Report metrics

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August 5, 2021

Patent Public Advisory Committee quarterly meeting

UNITED STATES
PATENT AND TRADEMARK OFFICE



IP5 Statistics Report

- The IP5 Offices publish an annual statistics report (IP5 SR)
- The IP5 SR provides various different metrics on patent application filings
- One of the metrics provided includes application pendency

USPTO workload

- The pendency measurement is intended to provide insights into the workload at each of the IP5 Offices.
- Although this may seem to be an indicator for the backlog in handling applications within the offices, it is not ideal as substantial periods in pending applications are due to awaiting actions from the applicant
- Current IP5 Statistic Report pendency metrics (both pendency first office action and pendency final action) both reflect this issue

2019 Statistics Report format

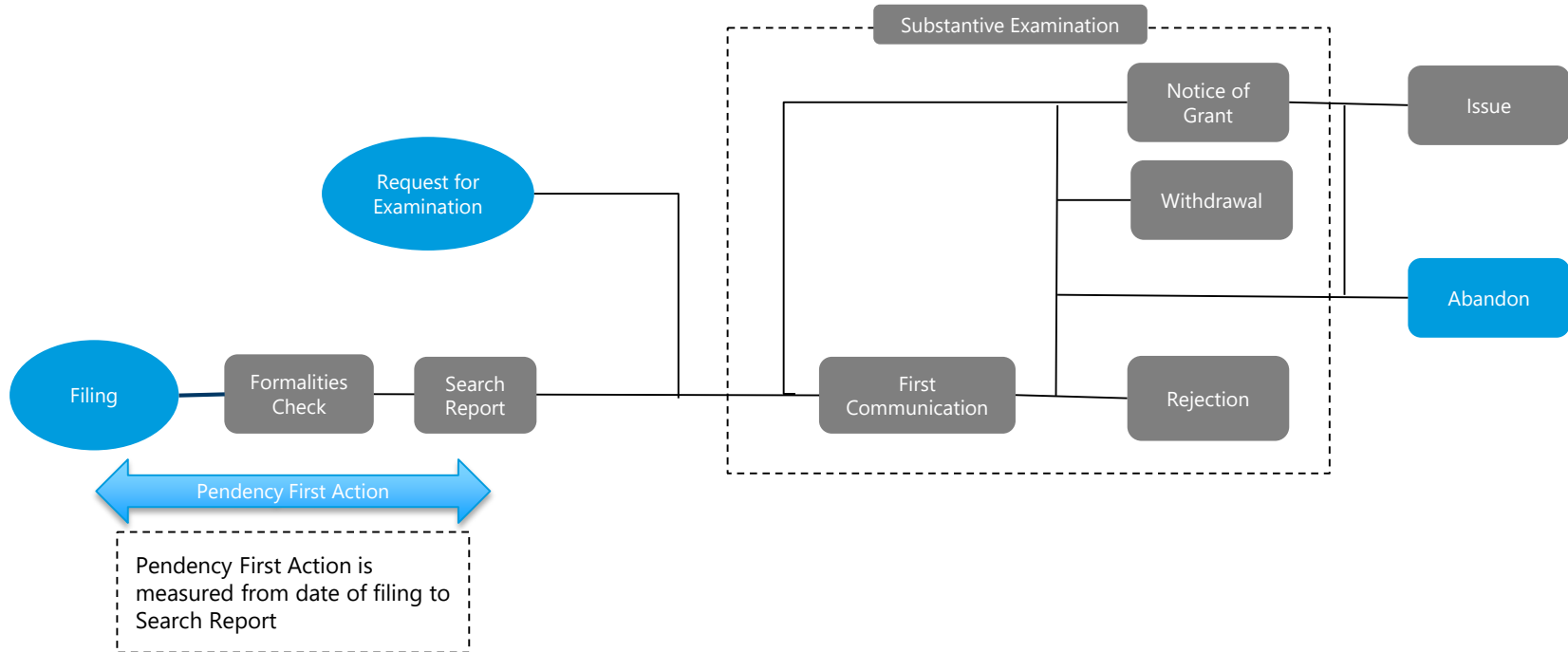
Table 4.3: STATISTICS ON PROCEDURES

Definitions of the various terms are given in Annex 2.

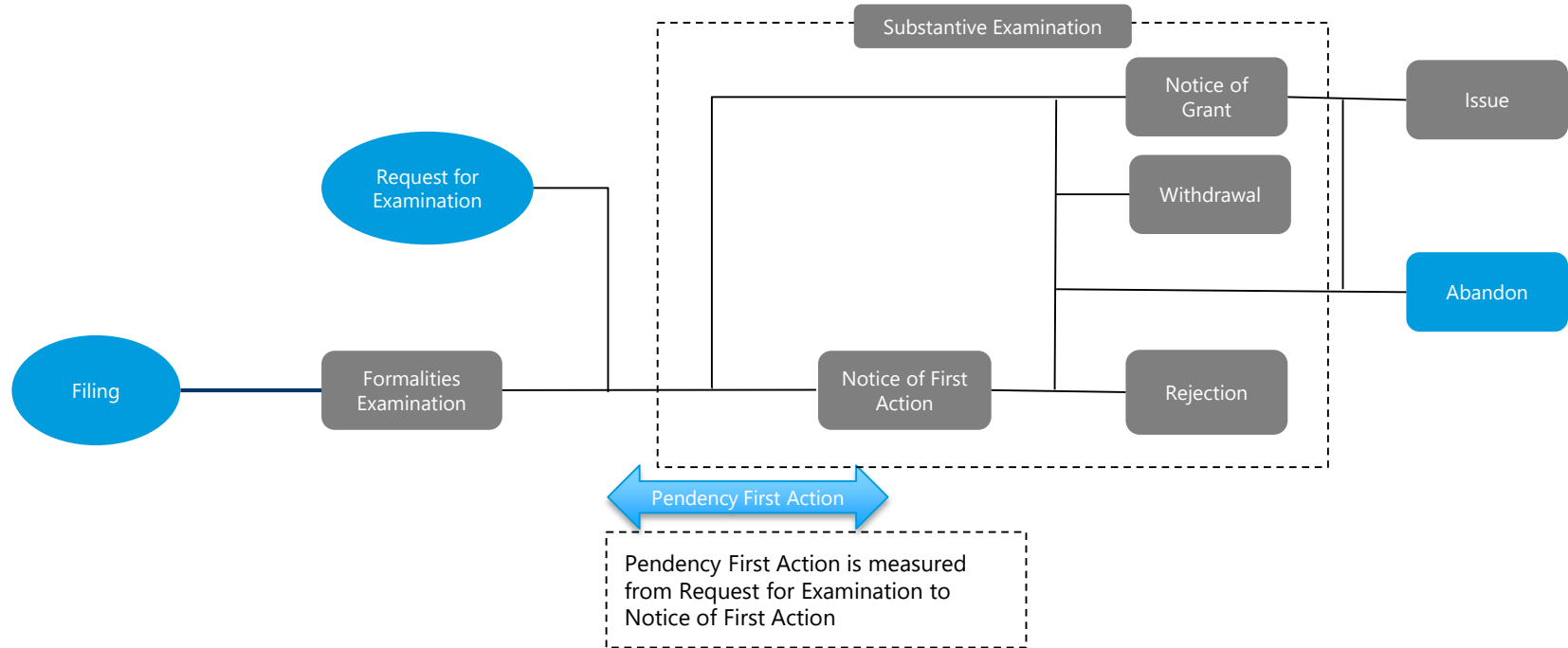
Progress in the procedure Rates in percentage	Year	EPO	JPO	KIPO	CNIPA	USPTO
Examination	2018	94.7	71.8	84.4	83.8	100.0
	2019	94.5	72.7	81.7	89.5	100.0
Grant	2018	62.2	75.3	65.2	53.5	74.5
	2019	63.9	74.9	68.8	44.3	77.3
Opposition	2018	3.2	0.6	-	-	-
	2019	2.7	0.6	-	-	-
Appeal on examination	2018	16.4	29.2	6.5	13.3	2.7
	2019	14.6	30.5	5.5	11.4	2.0
Pendency	Year	EPO	JPO	KIPO	CNIPA	USPTO
Awaiting request for examination	2018	95,643	633,244	235,969	294,079	-
	2019	98,161	619,007	244,276	266,567	-
Pending examinations	2018	371,884	168,679	166,878	1,968,203	546,792
	2019	335,293	173,494	174,064	2,218,145	578,138
Pendency first action (months)	2018	6.5	9.3	10.3	15.4	13.5
	2019	5.5	9.5	10.8	14.9	13.3
Pendency final action (months)	2018	31.8	14.1	15.8	22.5	21.7
	2019	28.1	14.3	15.6	22.2	21.8
Pendency invalidation (months)	2018	-	11.1	-	5.1	-
	2019	-	12.2	-	5.0	-

- = not applicable

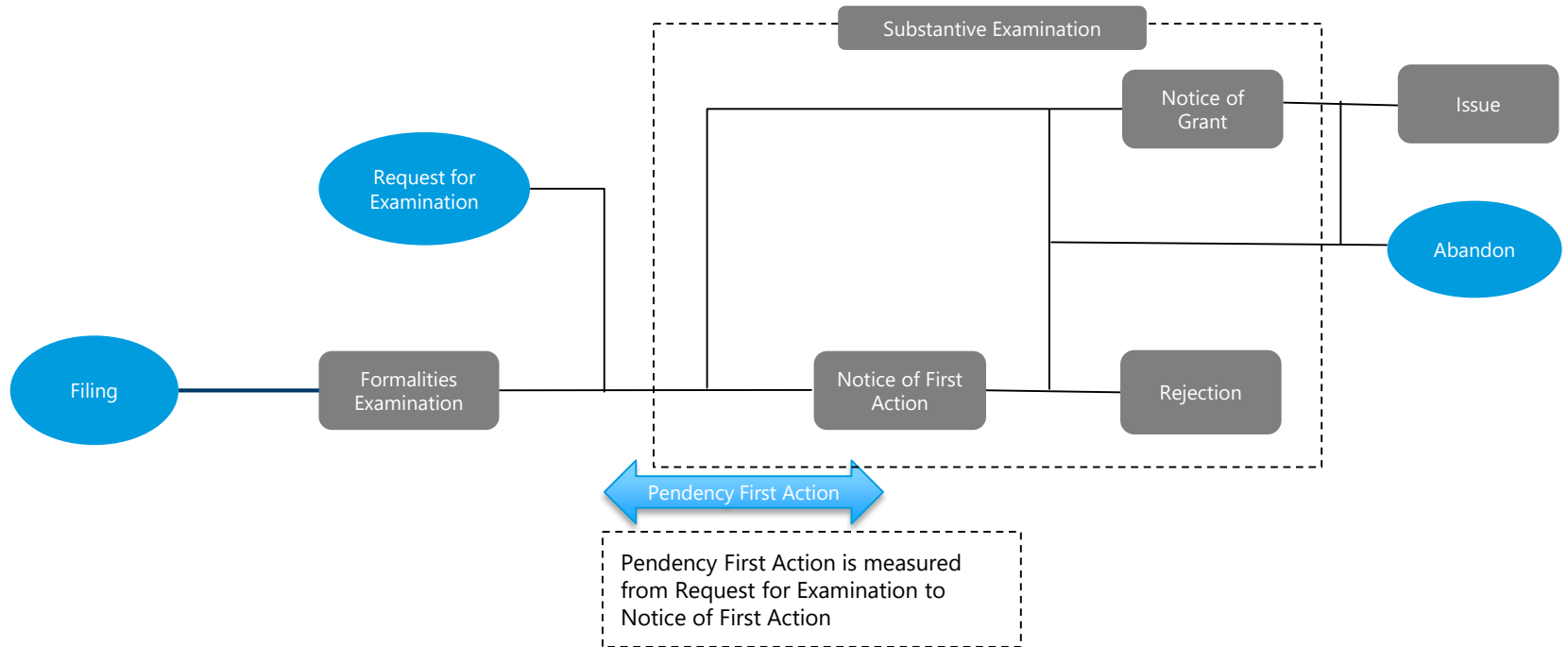
EPO pendency and workflow



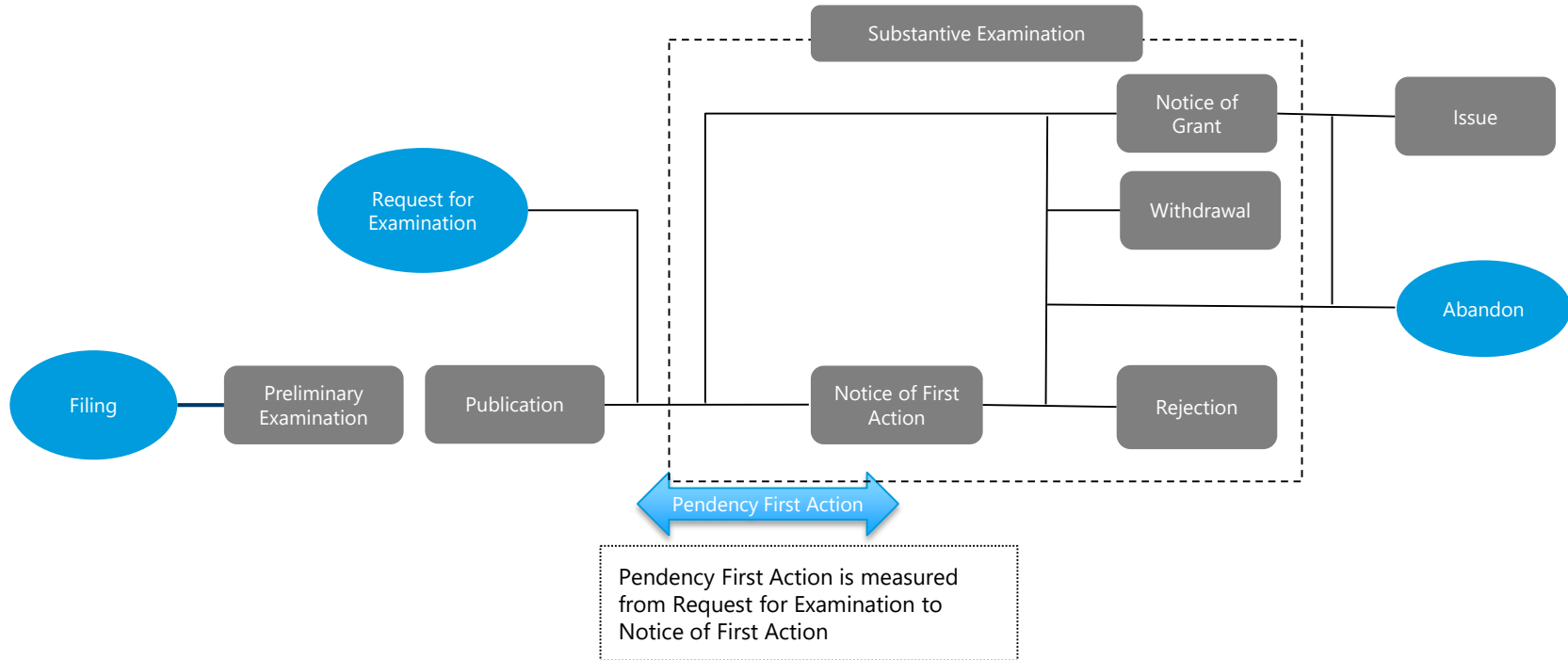
JPO pendency and workflow



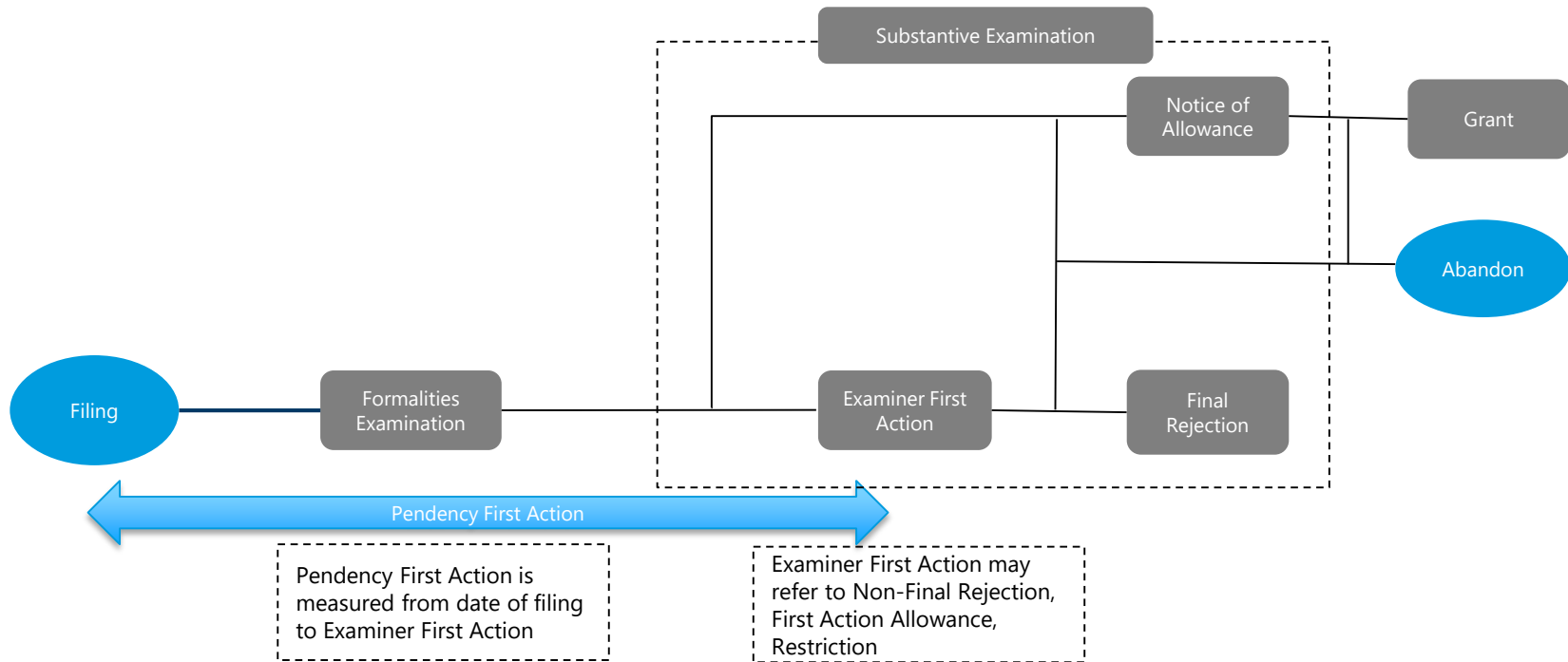
KIPO pendency and workflow



CNIPA pendency and workflow



USPTO pendency and workflow





Thank you!

For any questions, please email:

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